

4-19-2006

107576327

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>	Docket Number (Optional) <b>083-06</b>	Application Number <b>107576327</b>
	Applicant(s) <b>Tetsuya Nakabeppu and Tsutomu Tamura</b>	
	Filing Date <b>Herewith</b>	Group Art Unit <b>NA</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
NC/	AA	WO 2004/048480	06/10/2004	INTERNATIONAL				
NC/	AB	JP 2002-156521 A	05/31/2002	JAPAN				
NC/	AC	JP 2001-133624 A	05/18/2001	JAPAN				
NC/	AD	JP 2002-138203 A	05/14/2002	JAPAN				
NC/	AE	JP 2002-301785 A	10/15/2002	JAPAN				

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


EXAMINER <div style="text-align: center;">/Vivian Chen/</div>	DATE CONSIDERED <div style="text-align: center;">12/23/2007</div>
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**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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IAP15 Rec'd PCT/PTO 19 APR 2006

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
NCI	AF	JP 2002-249721 A	09/06/2002	JAPAN				
NCI	AG	JP 2004-12592 A	01/15/2004	JAPAN				
NCI	AH	JP 2004-161792 A	06/10/2004	JAPAN				

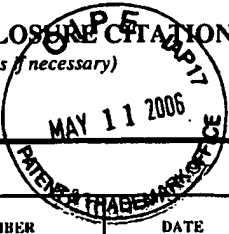
**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


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5-11-06

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>083-06</b>		Application Number <b>10/576,327</b>	
				Applicant(s) <b>Tetsuya Nakabeppu and Tsutomu Tamura</b>			
				Filing Date <b>April 19, 2006</b>		Group Art Unit <b>NA</b>	



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
NCI	AA	3,575,871	04/20/1971	Susi, et al.			

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
NCI	AB	JP43-25335 B	11/01/1968	JAPAN				

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER <b>Nivian Chen/</b>	DATE CONSIDERED <b>12/23/2007</b>
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